

Electronic Patent Application Fee Transmittal				
Application Number:	10589272			
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Title of Invention:	Plasma Processing Apparatus and Plasma Processing Method			
First Named Inventor/Applicant Name:	Kiyotaka Ishibashi			
Filer:	Marvin Jay Spivak/Brenda Harris			
Attorney Docket Number:	294901US26PCT			
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Miscellaneous-Filing:				
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Patent-Appeals-and-Interference:				
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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